

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/659,431	PARK, GEUN-YONG	
	Examiner Hai C. Pham	Art Unit 2861	

SEARCHED

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
347	263	4/28/2007	HP
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